

## Ana Londergan



Staff Engineer/Manager at Qualcomm MEMS Technologies

Nanotechnology

<http://www.directoryinventor.com/profile/view/0R58UCIU>

## Experience

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### Staff Engineer/Manager

Qualcomm MEMS Technologies

Nanotechnology

2005 - Present

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### Manager, ALD Process Development

Aixtron (Genus)

Nanotechnology

1998 - 2005

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## Patents (20)

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### Equipment and methods for etching of MEMS (1 worldwide citation)

Khurshid Syed Alam, Evgeni Gousev, Marc Maurice Mignard, David Heald, Ana R Londergan, Philip Don Floyd  
September 17, 2013: 08536059

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### Mems cavity-coating layers and methods

Ana R Londergan, Bangalore R Natarajan, Evgeni Gousev, James Randolph Webster, David Heald  
August 16, 2012: 20120206462-A1

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### MEMS cavity-coating layers and methods (4 worldwide citation)

Ana R Londergan, Bangalore R Natarajan, Evgeni Gousev, James Randolph Webster, David Heald  
April 24, 2012: 08164815

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### Apparatus for providing uniform gas delivery to a reactor

Jeremie J Dalton, M Ziaul Karim, Ana R Londergan  
October 20, 2011: 20110253046-A1

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### Methods of providing uniform gas delivery to a reactor (4 worldwide citation)

Jeremie J Dalton, M Ziaul Karim, Ana R Londergan  
July 19, 2011: 07981472

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### Transient enhanced atomic layer deposition (23 worldwide citation)

Gi Youl Kim, Anuranjan Srivastava, Thomas E Seidel, Ana R Londergan, Sasangan Ramanathan  
July 19, 2011: 07981473

## **Mems cavity-coating layers and methods**

Ana R Londergan, Bangalore R Natarajan, Evgeni Gousev, James Randolph Webster, David Heald  
September 30, 2010: 20100245979-A1

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## **Equipment and methods for etching of mems**

Khurshid Syed Alam, Evgeni Gousev, Marc Maurice Mignard, David Heald, Ana R Londergan, Philip Don Floyd  
September 2, 2010: 20100219155-A1

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## **MEMS cavity-coating layers and methods (11 worldwide citation)**

Ana R Londergan, Bangalore R Natarajan, Evgeni Gousev, James Randolph Webster, David Heald  
June 8, 2010: 07733552

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## **Method and apparatus for providing uniform gas delivery to a reactor**

Jeremie J Dalton, M Ziaul Karim, Ana R Londergan  
December 31, 2009: 20090324829-A1

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[View all \(20\)](#)